

Applicant:

David H. Hanes

Serial No.:

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Filed:

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For:

System and Method for Scene

Detection Information Storage

Director of the U.S. Patent and Trademark Office Washington, DC 20231

Attn: Art Unit 2173 - Examiner J. Cabeca

Docket No. 10010903-1

Examiner:

John W. Cabeca

Art Unit:

2173

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Technology Center 2100

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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Dear Sir:

The Supplemental Information Disclosure Statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office action on the merits, whichever event occurs last. 37 C.F.R. § 1.97(b). To comply with Applicant's duty of disclosure under 37 C.F.R. § 1.56, Applicant is submitting a proprietary document released to Applicant under non-disclosure agreement before the publication of a final version of the document. The final version of this document is now publicly available, but at a relatively prohibitive cost.

The information submitted with this Supplemental Information Disclosure Statement in the sealed envelope is considered a trade secret or proprietary by Applicant and is being submitted for consideration under M.P.E.P § 724. A petition under 37 C.F.R. § 1.59 and fee therefore are also being submitted herewith to expunge the information contained in the envelope, should the return of the information be appropriate pursuant to 37 C.F.R. § 1.59.

If the undersigned representation may be of any assistance, she can be contacted at 214-855-7585 at the convenience of the Examiner.

Date: Jan

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Respectfully submitted,

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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Director of the U.S. Patent and Trademark Office, Washington, D.C. 2023 ATTN; Art Unit 2173 Examiner J. Cabeca.

Vikki R. Colvin

1-9.02

Date